

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	5721477
<b>Application Number:</b>	10524809
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	1620
<b>Title of Invention:</b>	Single-shot semiconductor processing system and method having various irradiation patterns
<b>First Named Inventor/Applicant Name:</b>	James S. Im
<b>Customer Number:</b>	21003
<b>Filer:</b>	David W. Schalk
<b>Filer Authorized By:</b>	
<b>Attorney Docket Number:</b>	A35416-PCT-USA (070050.27
<b>Receipt Date:</b>	17-JUL-2009
<b>Filing Date:</b>	15-FEB-2005
<b>Time Stamp:</b>	11:38:59
<b>Application Type:</b>	U.S. National Stage under 35 USC 371

### Payment information:

Submitted with Payment		no			
File Listing:					
Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	NPL Documents	Bergmann_Nucleation.pdf	1199645	no	16
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2	NPL Documents	Biegelsen_Origin.pdf	234450 ace1846a88176ca9f6dc97b79672435a33cda7	no	3
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3	NPL Documents	Boyd_LaserProcessing.pdf	180212 5c52f306131426aef80c31408ff1fc646493285c5	no	3
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4	NPL Documents	Brotherton_Characterisation.pdf	297835 3ae1f6a946d73327b14b48ba8c51c0bdc61d4d	no	4
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5	NPL Documents	Crowder_Parametric.pdf	713349 f726abef1c71cd8f81d622356c8f5bdc2f10d01a	no	7
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7	NPL Documents	Dassow_Laser_Crystallization.pdf	331549 bdda1512d51384dc5a1931c66582a73d1931a3bf	no	4
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8	NPL Documents	Dassow_Laser_Crystallized.pdf	712303 c22db4b270cc81d482d97d6ae956f82b597246	no	5
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9	NPL Documents	Dassow_NdYVO4.pdf	527400 133e575c3bc37812d08a7d501da6c5c0896e	no	6
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10	NPL Documents	Dimitriadis_Effect.pdf	1044162 a3a8ec0be9386d0e18b24374532d493384263	no	11
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11	NPL Documents	Geis_Crystallographic.pdf	354241 66f7464ac252274b64c9ba0c3d3121d32ef e8fcb3	no	4
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12	NPL Documents	Geis_Silicon.pdf	299946 cd110ac7996c47b18d6f5dc95dcd3b1e4888 85ac	no	3
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16	NPL Documents	Hayzelden_Silicide.pdf	2248864 6c98e17d9d617ab2cd26cc2544cd99a582 b33	no	19
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17	NPL Documents	Im_Provisional_Application_No _60503419.pdf	1233723 5f86da9276ba3036a16de21235b6d4184b1 bc5c4	no	27
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39	NPL Documents	MicroLasLasersystem_UVOptics.pdf	1201734 00627d8b1501d43d46c3d137ffcd15d10dc13f	no	12
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52	NPL Documents	Voutsas_A_new_era.pdf	846820 62baf773bc378bdad18c3d93c13dc433217efb3c	no	13
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54	NPL Documents	Voutsas_Effect.pdf	1602257 45493e487a5a542f526a4b70bca6778a0c50ba7e	no	16
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55	NPL Documents	Weiner_LaserAssisted.pdf	310518 ec2843dc23dbae41a015070f2936591481ab4	no	9
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57	NPL Documents	White_Characterization.pdf	750834 26127162enc81E32ae59344d674d5f0142f 880	no	9
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Total Files Size (in bytes):			50912506		
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><b><u>New Applications Under 35 U.S.C. 111</u></b> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><b><u>National Stage of an International Application under 35 U.S.C. 371</u></b> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p> <p><b><u>New International Application Filed with the USPTO as a Receiving Office</u></b> If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.</p>					